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APR 25 2006

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Examiner Thao Le	U.S. Patent and Trademark Office	571-273-8300	
<b>From:</b>	Ramyar M. Farid	<b>Direct Phone:</b>	202.756.8146
<b>E-Mail:</b>	rfarid@mwe.com	<b>Direct Fax:</b>	202.756.8087
<b>Sent By:</b>	Matilda Mason	<b>Direct Phone:</b>	202-756-8661
<b>Client/Matter/Tkpr:</b>	60188-751	<b>Original to Follow by Mail:</b>	No
		<b>Number of Pages, Including Cover:</b>	10
<b>Re:</b>	<b>Application No.:</b>	<b>10/754,518</b>	
	<b>Attorney Docket No.:</b>	<b>60188-751</b>	

Message:

This Amendment is being filed in response to the Office Action dated January 25, 2006.

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U.S. practice conducted through McDermott Will & Emery LLP.  
600 Thirteenth Street, N.W. Washington, D.C. 20005-3096

Telephone: 202.756.8000

Docket No.: 060188-0751

**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****RECEIVED  
CENTRAL FAX CENTER****APR 25 2006**

In re Application of : Customer Number: 20277  
 Yoshiharu HIDAHA, et al. : Confirmation Number: 8259  
 Application No.: 10/754,518 : Group Art Unit: 2814  
 Filed: January 12, 2004 : Examiner: Thao X. Le

For: SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND METHOD FOR  
 FABRICATING SEMICONDUCTOR DEVICE

Mail Stop Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☐ Also attached:

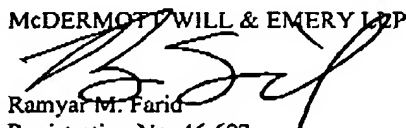
The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	10	20	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL &amp; EMERY LLP

  
 Ramyar M. Farid  
 Registration No. 46,692

600 13<sup>th</sup> Street, N.W.  
 Washington, DC 20005-3096  
 Phone: 202.756.8000 RMF:MWE  
 Facsimile: 202.756.8087  
 Date: April 25, 2006

Please recognize our Customer No. 20277 as our  
 correspondence address.

**APR 25 2006**

Docket No.: 060188-0751

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
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	:	
Application No.: 10/754,518	:	Group Art Unit: 2814
	:	
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	:	

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METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 25, 2006, having a three-month shortened statutory period for response set to expire on April 25, 2006, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.